SIDJC-SB Connect 2025

Career, Research, and JSID Dialogue —

Date: Dec. 6th, 2025 (the day after IDW'25)

Venue: ROOM 5, Yale Yale A Building, 1-5 Matsubara-cho,

Minami-ku, Hiroshima City

(Directly connected to JR Hiroshima Station South Exit)

Participation Fee: 2,000 JPY

(flat rate for students and professionals)

Souvenir: Aerial display souvenir gift for all paid participants

Program

09:00-09:15: Registration & Student Poster Setup

09:15-09:45: Career Talk by a Display Industry Representative

[Development of Lithography Equipment Linking

Field Operations to Design]

(in Japanese) - Speaker: Yohei Nawaki, Ushio Inc.

09:45-10:30 : Break & Poster Session

(Posters will be in English; Q&A in Japanese is acceptable)

10:30-10:50: Student Presentation 1 (Doctoral Student in English)

- Speaker: Hiroki Takatsuka, Utsunomiya University

10:50-11:10: Student Presentation 2 (Doctoral Student in English)

- Speaker: Ma Chuanyu, Kyushu University

11:15-12:00: Introduction to the JSID Review Process

~ Do's and Don'ts from the Perspectives of

Associate Editors and Reviewers ~

- Speaker: Prof. Abhishek Kumar Srivastava, Editor-in-Chief, JSID

12:00 : Break & Group photo

12:15-13:00 : JSID Authors-Editors Networking Session

Participants:

- Prof. Abhishek Kumar Srivastava
- Prof. Ioannis (John) Kymissis
- Additional participants to be announced

13:00-13:30 : Closing & Clean-up

SID日本支部

Student Branch

Organized by SID Japan Chapter Student Branch

For registration or questions, email us at:

Connect2025(at)yamamotolab.science

(Please replace (at) with @ when sending the email.)

Capacity

120

People